Exhibit R-2, RDT&E Budget Item Justification: PB 2017 Office of the Secretary Of Defense				Date: February 2016								
Appropriation/Budget Activity 0400: Research, Development, Te Advanced Technology Developme	est & Evalua ent (ATD)	ation, Defen	se-Wide I B	A 3:	R-1 Program Element (Number/Name) PE 0603680D8Z / Defense Wide Manufacturing Science and Technology P				ology Progra	am		
COST (\$ in Millions)	Prior Years	FY 2015	FY 2016	FY 2017 Base	FY 2017 OCO	FY 2017 Total	FY 2018	FY 2019	FY 2020	FY 2021	Cost To Complete	Total Cost
Total Program Element	158.554	88.135	156.743	158.398	-	158.398	136.848	116.354	89.326	70.288	Continuing	Continuing
P680: Manufacturing Science and Technology Program	111.117	22.785	20.245	21.311	-	21.311	22.078	23.798	31.188	35.372	Continuing	Continuing
P350: Manufacturing Innovation Institutes	47.437	65.350	136.498	137.087	-	137.087	114.770	92.556	58.138	34.916	Continuing	Continuing

### A. Mission Description and Budget Item Justification

Defense-wide Manufacturing Science and Technology (DMS&T), established within the Manufacturing Technology Program directed in Title 10 USC Section 2521, provides the Department with a comprehensive manufacturing program to achieve the strategic goals of focused technology, improved acquisition across the life cycles, and cost-effective logistics. By designing for manufacturability early in development, anticipated results will have an impact on increasing reliability and decreasing the life cycle burden of weapon systems. The mission to anticipate and close gaps in defense manufacturing capabilities and drive significant system life cycle affordability benefits makes DMS&T an increasingly important leveraging tool in the current budget environment.

DMS&T will: 1) address manufacturing enterprise game-changing initiatives that are beyond the scope of any one Military Department or Defense Agency or platform and, 2) establish and mature cross-cutting manufacturing processes required for transitioning emerging technologies which impact the time lines, affordability, and productivity of acquisition programs and shorten the deployment cycle times.

The DMS&T program is fundamental to a coordinated development process. Concurrent development of manufacturing processes with the S&T development enables the use of emerging technologies. Key technical areas for investment for DMS&T include Advanced Electronics and Optics Manufacturing, Advanced Materials Manufacturing, and Enterprise and Emerging Manufacturing. Advanced Electronics and Optics addresses advanced manufacturing technologies for a wide range of applications such as sensors, radars, power generation, switches, and optics for defense applications. Advanced Materials addresses advanced manufacturing technologies for a wide range of materials such as composites, metals, ceramics, nanomaterials, metamaterials, and low observables. Enterprise and Emerging Manufacturing technologies and enterprise business practices for defense applications. Key focus areas include the industrial information infrastructure, advanced design/qualification/cost tools, supply network integration technologies and management practices, direct digital (or additive) manufacturing, machining; robotics, assembly, and joining.

The Manufacturing Innovation Institutes program funding is also included in this program element. Technical innovation and leadership in manufacturing are essential to sustaining the foundations of economic prosperity to enable our military to maintain technological advantage and global dominance. To support these goals, Institutes for Manufacturing Innovation Institutes (MII) will serve as regional hubs to accelerate technological innovation into commercial application and concurrently develop the educational competencies and production processes via shared public-private sectors. The establishment of the MIIs, supported by resources from multiple U.S. Government agencies, will spur industry cost-share for manufacturing innovation and quickly develop a pathway for technology-focused regional hubs for collaboration among government, industry, and academia that will meet critical government and Warfighter needs. The concept of these institutes is described in the President's

Exhibit R-2, RDT&E Budget Item Justification: PB 2017 Office of the Secretary Of Defense			Date:	Date: February 2016		
Appropriation/Budget Activity		R-1 Program El	ement (Number/Name)			
0400: Research, Development, Test & Evaluation, Defense-Wi Advanced Technology Development (ATD)	de / BA 3:	PE 0603680D8Z	I Defense Wide Manufa	acturing Science and Te	echnology Program	
National Science and Technology Council report by the Advan	ced Manufactur	ing National Progr	am Office entitled, "Nati	onal Network for Manu	facturing Innovation: A	
Preliminary Design," published in January 2013.						
B. Program Change Summary (\$ in Millions)	<u>FY 2015</u>	<u>FY 2016</u>	FY 2017 Base	FY 2017 OCO	FY 2017 Total	
Previous President's Budget	90.966	157.056	119.714	-	119.714	
Current President's Budget	88.135	156.743	158.398	-	158.398	
Total Adjustments	-2.831	-0.313	38.684	-	38.684	
<ul> <li>Congressional General Reductions</li> </ul>	-	-				
<ul> <li>Congressional Directed Reductions</li> </ul>	-	-				
<ul> <li>Congressional Rescissions</li> </ul>	-	-				
Congressional Adds	-	-				
<ul> <li>Congressional Directed Transfers</li> </ul>	-	-0.313				
Reprogrammings	-	-				
SBIR/STTR Transfer	-2.796	-				
<ul> <li>DoD rebalancing of accounts</li> </ul>	-	-	-0.400	-	-0.400	
<ul> <li>Reprogramming for Cancelled Accounts</li> </ul>	-0.035	-	-	-	-	
Economic Assumptions	-	-	-0.916	-	-0.916	
<ul> <li>Establish two additional Manufacturing Innovation Institutes (#7 and #8)</li> </ul>	-	-	40.000	-	40.000	

#### **Change Summary Explanation**

Two project codes are used in this Program Element (PE) to distinguish between the level of funding for the Core OSD Manufacturing Technology program (P680) and the Manufacturing Innovation Institutes (P350). The growth in funding in this PE from prior President's budgets is wholly associated with the addition of the MII (P350) program.

P350 Manufacturing Innovation Institutes (MII) - issues affecting year-to-year changes:

1) Cooperative Agreement (CA) five-year funding profiles for each of eight institutes are not straight-line funded in each year, but instead are incrementally increased and decreased across five fiscal years, with the third year being the peak year. This profile leverages the ability to attain matching funds from industry and academia partners for R&D projects.

2) The number of institutes changes from five in FY 2015 to six in FY 2016, and to eight in FY 2017.

3) FY 2016 and FY 2017 are the peak years for funding for the MII program, with significant annual decreases programmed annually subsequent to FY 2017.

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense							Date: Febr	uary 2016				
Appropriation/Budget Activity 0400 / 3				R-1 Program Element (Number/Name)Project (Number/Name)PE 0603680D8Z / Defense WideP680 / Manufacturing ScienceManufacturing Science and TechnologyTechnology ProgramProgramProgram			<b>1e)</b> Science and	d				
COST (\$ in Millions)	Prior Years	FY 2015	FY 2016	FY 2017 Base	FY 2017 OCO	FY 2017 Total	FY 2018	FY 2019	FY 2020	FY 2021	Cost To Complete	Total Cost
P680: Manufacturing Science and Technology Program	111.117	22.785	20.245	21.311	-	21.311	22.078	23.798	31.188	35.372	Continuing	Continuing

#### A. Mission Description and Budget Item Justification

The DMS&T program has a two-pronged approach: 1) technology initiatives and 2) specific single projects. Technology initiatives, in collaboration with the Joint Defense Manufacturing Technology Panel (JDMTP) and industry, identify and develop investment strategies to advance the manufacturing processes needed to support the specific technology. Above-the-shop-floor investments focus on new manufacturing processes that have potential to significantly improve manufacturing efficiencies. Single specific projects address investment opportunities not associated with selected technology initiatives and enable the program to respond to urgent, compelling manufacturing needs and provide seed funding to more high risk-high payoff technologies.

Data calls are launched through two methods to identify technology initiatives and single specific issues requiring investment. One method is through the JDMTP. The JDMTP is comprised of the ManTech Directors from the Services, Defense Logistics Agency, and Office of Secretary of Defense (OSD). The call is distributed through the ManTech Directors to the four JDMTP sub panels: Metals Processing and Fabrication Subpanel, Composites Processing and Fabrication Subpanel, Electronics Processing and Fabrication Subpanel, and Advanced Manufacturing Enterprise Subpanel. Potential candidates are evaluated by the JDMTP based on criteria set forth in the call and announcements, and then down-selected for further development prior to final selection. The other method is through Broad Agency Announcements to industry. Priority is given to investments that support affordability and producibility of critical enabling manufacturing processes including "above the shop floor" (lean and business technologies facilitating interoperable manufacturing). Final projects are selected by the OSD ManTech Director, considering input from the JDMTP and Director of Manufacturing, and as approved by Deputy Assistant Secretary of Defense, Manufacturing and Industrial Base Policy (MIBP). Technology initiatives and projects are executed at the Component level.

B. Accomplishments/Planned Programs (\$ in Millions)	FY 2015	FY 2016	FY 2017
Title: Advanced Electronics and Optics	13.899	12.182	12.550
<b>Description:</b> Advanced Electronics and Optics is a series of efforts addressing advanced manufacturing technologies for a wide range of applications such as sensors, radars, power generation, switches, and optics for defense applications. Focal points are productivity and efficiency gains in the defense manufacturing base to accelerate delivery of technical capabilities to impact current warfighting operations, and manufacturing technologies to reduce the cost, acquisition time and risk of our major defense acquisition programs. Future efforts will focus on advances in fuel cells, lasers, enhanced acuity microdisplays, and transparent ceramics for opto-mechanical and armor applications.			

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense				Date: February 2016		
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Project (N P680 / Ma Technolog	nd			
B. Accomplishments/Planned Programs (\$ in Millions)		F	( 2015	FY 2016	FY 2017	
The Transparent Ceramic Initiative will address DoD applications for ele components, such as windows. Typical materials include: sapphire, ALC improved ballistic strength for battlefield armor and personnel protection spinel scale-up, Nanocomposite Optical Ceramics (NCOC) powder scal	ectro-optics, including fibers, films, and bulk solid sta ON, and spinel. Transparent ceramics offer the poter n. Investments include but are not limited to: high stro le-up, infrared windows, and curved transparent cera	te ntial for ength amics.				
Projects:						
Silicon Carbide (SiC) High Efficiency Power Switches (FY 2015): Enable architectures at higher voltages, higher frequencies, less volume and w fuel consumption), and better power quality that allows flexible architect Demonstrated on a naval power conditioning application, reduced the w pulsed diode \$/Amp from \$0.40 at 6kv to \$0.27 at >20kV. Applications i DDG51 Flight III (Electric Ships Office, PMS-320); and Air Force – F-35	e a new class of power electronics that allows flexibl eight, higher temperatures, higher efficiency (reduce cures with enhanced electronics in a smaller footprint reight by 90% and volume by 30%. Reduce high volt nclude Army - Platform Modernization Program Navy , F-22 (MEA & F-35 Offices).	e new d :. age y -				
Photonic Crystals for Thermal Beacons (FY 2015): Drive affordability, r to enable Identification of Friend or Foe (IFF), producing a thermal beac Thermal Beacon, Intelligence Surveillance and Reconnaissance (ISR) t AC-130/F15/F18/Sniper Pod/Litening Pod, MWIR - Hand Held Imagers, INOD Blk3. The benefit is immediate upon reaching the battlefield. Bei ability to employ new tactics, techniques and procedures (TTP).	nanufacturability, and quality photonic crystal produc con using photonic crystals. Systems impacted inclu hat use Mid-Wave Infrared (MWIR) including MQ1/M as well as In-line WPN's Sights such as the HISS a nefits to the Warfighter include decreased fratricide a	ction de the 1Q9/ nd and				
Mini Short-wave Infrared (SWIR) Cameras and Imagers (FY 2015-2016 cameras to the warfighter and develop wafer level processing technique focal plane array (FPA)/ camera assembly. Will establish the industrial B Reduced unit cost allows more individuals to carry imagers; 6x improve 3cm3 to 1cm3; 3x reduced weight from 120 g to 40 g. Applications inclusions system (JETS), IDNST, PAWS, and MTS-B.	i): Expedite the transition of 10 um (TEC)-less SWIR es to improve yield and reduce contaminants in the S base for SWIR technology systems and components d cost, reduced from \$30K to \$5K; 3x reduced size f ide COSI, INOD, COS3, AWST, Joint Effect Targetin	SWIR rom ng				
Mini Vis - SWIR Cameras and Imagers (FY 2016): Develop a manufacture spectral band of Visible, Near Infrared (NIR), and Short-wave Infr SWIR laser pointers and illuminators. Applications include: COSI, INOD Joint Effect Targeting System (JETS), Integrated Day/Night Sight Techr System (MTS-B).	uring capability to produce one camera that can see ared (SWIR); while being compatible with visible, NI 0, COS3, Advanced Weapon Sight Technology (AWS nology (IDNST), PAWS, and Multispectral Targeting	the R, and ST),				

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the	e Secretary Of Defense		Date: F	ebruary 2016	6	
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Proje P680 <i>Techr</i>	<b>Project (Number/Name)</b> P680 I Manufacturing Science and Technology Program			
B. Accomplishments/Planned Programs (\$ in Millions)			FY 2015	FY 2016	FY 2017	
Manufacturability of Vertical Cavity Surface Emitting Lasers (VCSE sights, laser illuminators, and laser designators as measured by siz laser-based systems due to lower cost. Provide clearer illumination ID, weapons ID; covert wavelengths; improve packaging (10-100x hrs.). Applications include PUMA, RAVEN, TigerShark, Anubis, Sp AngelFire, MAV-OBAT, nLoss, LOS-short, CLRF, Joint Effect Targ STINGER, ARGUS, and others. Manufacturability of Vertical Cavity Surface Emitting Lasers (VCSE produce a Multi-Function Laser Illuminator and Pointer that deliver: Short-wave Infrared (SWIR) Laser Pointers plus NIR and SWIR illugive the warfighter commonality with all other weapon systems and increase in efficiency and output power to meet critical needs for commonality.	ELs) – Phase I (FY 2015) Develop better performance for ze, weight and power and wider scale deployment of critic in critical for positive Identification (ID) Friend vs. Foe, facial smaller and lighter products); increase reliability (10,000 bectre-FINDER, Speckles, TigerMoth, WAAS, PAWS, IPO jeting System (JETS), IDNST, TLDS, Big Safari, OEF, OIF ELs) – Phase II (FY 2016-2017): Develop the capability to s the functionality of five different devices (Green, NIR, ar uminators) in a single, high-power, lightweight unit, which d be covert. Would provide the SWIR VCSEL a three-fold overt illumination in both High Definition and SXGA forma	laser cal DS, <del>-</del> , nd would ts.				
Applications include: PUMA, RAVEN, TigerShark, Anubis, Spectre AngelFire, MAV-OBAT, nLoss, LOS-short, CLRF, Joint Effect Targ STINGER, and ARGUS, others.	-FINDER, Speckles, TigerMoth, WAAS, PAWS, IPODS, Jeting System (JETS), IDNST, TLDS, Big Safari, OEF, OIF	=,				
Vital Infrared Sensor Technology Acceleration (VISTA) High Temp Establish a critical domestic industrial base for MWIR focal plan and (IR) FPAs to reduce size, weight, power, and cost while increasing Will achieve wafer production scale-up to 40-50 wafers per month extending cooler lifetimes 150% - 200% as a result of reduced stree sensor lifecycle maintenance cost. Applications include: Air Force: LWIRST (F-15), Targeting System Enhancements (MQ-9, F-16), C Degraded Visual Environment, Rotary Wing Pilotage; Navy: Shipbe Surveillance for USMC, UAV, and Navy: BAMS, F-18 (Advanced II Affordable Modular Panoramic Photonics Mast.	Mid-Wave Infrared (MWIR) Detectors (FY 2015-2017): rays (FPA) having capabilities in III-V antimony-based Infr yield and operability as an alternative to current technolo while shortening sensor turn-on and cool down time by 50 ess during temperature cycling, and substantially reducing EODAS Enhancement (F-35), EOTS Enhancement (F-35 overhead Persistent Infrared (OPIR); Army: Next Gen FLIF oard Multifunction Sensors (APDIS), Overhead Persistent RST), EO/IR Standard Integration System (EISIS), and	rared gy. )%, the 5), ₹,				
Improved Focal Plane Array (FPA) – Hyperspectral – Phase II (FY Wave Infrared (LWIR) Hyperspectral (HIS) applications. Up to \$1M arsenic-doped silicon blocked impurity band (Si:As BIB) detectors. Cadmium Telluride (MCT). Improved reliability, maintainability, and	2015-2017): Demonstrate utility of III-V based FPAs for L l/year/sensor reduction in system life cycle costs compare Significant reduction in up-front costs compared to Mercu availability, along with increased detection range.	ong- ed to iry				

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the	e Secretary Of Defense		Date: F	ebruary 2016	6			
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Projec P680 Techn	<b>iject (Number/Name)</b> 30 I Manufacturing Science and hnology Program			Project (Number/Name) P680 I Manufacturing Scie Technology Program		and
B. Accomplishments/Planned Programs (\$ in Millions)		[	FY 2015	FY 2016	FY 2017			
Organic Light Emitting Diode (OLED) Microdisplays - Phase II (FY producing an ultra-high resolution, high brightness, high contrast, f manufacturing processes: Silicon on Insulator (SOI) and Direct Pat 5X longer lifetime of displays, reducing life cycle costs. \$\$221.7M s (27,700 displays between 2017-2032) x \$8K/unit savings). Applica Apache, EVA, F-18, F-15, F-16, affordable color/monochrome disp to fully use sensors and cuing/augmented reality hardware. Radar Affordability Initiative (RAI) (FY 2015): RAI offers DoD comm radar and electronic warfare (EW) systems. The RAI approach en design. The DoD also receives Government Purpose Rights (GPR sole source dependencies. At the completion of RAI projects, DoD limiters. Additionally, the DoD will have evidence that applying the The RAI Affordable Transmit-Receive Modules (ATRM) project is a maintaining module form factor, performance, and reliability) throug chips into a single, super regulator chip and development of a high Radar Affordability Initiative – SPS-49 (FY 2016-2017): The SPS-4 affordable upgrade of the AN/SPS-49A(V)1 below deck equipment reliability, high availability operational environment. This upgrade p Development Model 49AUs built using production processes and c maintained and easily upgraded. The 49AUs will be installed on U Nanocomposite Optical Ceramics (NCOC)(FY 2016-2017): Advance large reduction of emissivity at elevated temperatures experienced by increasing the signal to noise ratio. Effort will focus on scale-up AIM-9X full rate production quantities.	2016-2017): Establish manufacturing capability for ull color microdisplay at a low unit cost. Mature and com terning technologies to enable a 5X improvement in yield savings for aviation and Enhanced Visual Acuity (EVA) get tions include F-35 Heads-up Helmet Mounted Display Sy alays with high brightness and high contrast to enable Wa non, modular building blocks performing like functions ac ables acquisitions to complete subcomponents within a ) for each investment, enabling competition, and breaking will have GPR for T/R Modules, solid state amplifiers, ar common, modular approach shortens hardware upgrade aimed at reducing the cost of the G/ATOR T/R Module (w gh incorporating the functionality of three separate regula power amplifier (HPA) 2nd source. 9 program is focused on the design and development of with modern, sustainable, maintainable equipment in a h program will design, fabricate and test three Engineering lesigned with an open system architecture which is easily 1. S. Navy ships for operational testing and evaluation. ce manufacturing maturity of NCOC to replace sapphire. during flight makes NCOC more favorable for a missile of NCOC dome manufacturing processes to meet projected	bine J and oggles 'stem, irfighter ross g id times. 'hile itor an high y The dome d						
<b>FY 2015 Accomplishments:</b> Silicon Carbide (SiC) High Efficiency Power Switches: Completed Swafer seed crystals to 133 mm diameter wafer. Continued work on	Stage 1 & Stage 2 of 3-Stage expansion of Gen 2 SiC alternative approach to reduce defects in production Ge	n						

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the	e Secretary Of Defense		Date: F	ebruary 2016	6
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Proje P680 Techn	<b>Project (Number/Name)</b> P680 I Manufacturing Science and Technology Program		
B. Accomplishments/Planned Programs (\$ in Millions)			FY 2015	FY 2016	FY 2017
1 150 mm SiC crystals. Continued progress on 3 x 150 mm Hot-Wa characterization of multiple 1200V SiC trench Metal Oxide Semicor	all SiC epi reactor development. Completed fabrication ar nductor Field Effect Transistor (MOSFET) fab lots.	nd			
Mini Short-wave Infrared (SWIR) Cameras and Imagers: Complete to establish starting cycle time and identify improvement area; initia polishing, and FPA level anti reflective coating processes; and ther less data collection and algorithm development.	d the following: baseline focal plane array (FPA) producti al development of wafer level diamond point turning, FPA mos electric cooler (TEC) stabilized camera core used fo	on lot level r TEC-			
VISTA High Temp MWIR Detectors: Continued efforts to integrate under the larger VISTA program into the F-35 EODAS system. Beg supporting integrated dewar cooler assembly field testing.	High Operating Temperature MWIR FPA technology deve gan FPA fabrication, process optimization and maturatior	eloped n, and			
Manufacturability of Vertical-Cavity Surface Emitting Lasers (VCSE yield of high power pump modules; built and tested prototype VCSE demonstration with monoblock laser; explored approaches to improt threshold for low power illuminator lifetime reliability; and fulfilled cu	ELs) - Phase I: implemented process changes to improve EL pump modules; completed high power pump module ove low power illuminator beam uniformity; met program ustomer orders for high power illuminators.				
Improved Focal Plane Array (FPS) - Hyperspectral – Phase II: awa for Long-Wave Infrared (LWIR) Hyperspectral (HIS) applications. U compared to arsenic-doped silicon blocked	rded contract to demonstrate utility of III-V based FPAs Ip to \$1M/year/sensor reduction in system life cycle costs	5			
Photonic Crystals for Thermal Beacons: established photonic crystal included growing, dicing, etching, and vacuum sealing. Leveraged Executed the photonic crystal emitter fabrication steps to enable a	al foundry processes, layout, and flow. Processes establ prior investment in development of prototype beacons. transition from MRL 4 to MRL 7.	lished			
Radar Affordability Initiative: initiated Affordable Transmit-Receive I incorporating three separate regulator chips into one; began conso migrating to a non-hermetic organic package; researched and idem Board (PCB) material trade studies. PCB material Megatron 6(N) v Quad Flat No-leads (QFN) packaging trade study (Sumitomo Bake milestones were achieved.	Modules (ATRM) Super Regulator design activity for lidation of functionality using SiGe MMIC technology as v tified second source opportunities; completed Printed Cir was selected to best meet performance goals. Completed lite {Gen7} material selected). Critical Design Review (CE	vell as cuit I the DR)			
FY 2016 Plans:					

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the	Secretary Of Defense	Da	ate: F	ebruary 2016	6
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	<b>Project (Nun</b> P680 / Manuf Technology P	oject (Number/Name) 80 / Manufacturing Science a chnology Program		
B. Accomplishments/Planned Programs (\$ in Millions)		FY 20	)15	FY 2016	FY 2017
Mini Short-wave Infrared Cameras and Imagers: establish plan for d hybridization, sensor packaging, and camera calibration efforts.	device transitions; continue wafer growth/processing,				
Mini Vis - SWIR Cameras and Imagers: completed design and deve substrate removal; developed specifications for vis-SWIR devices; a response to <900 nm.	elopment of additional manufacturing processes for sens and developed test and evaluation methods for extended	or I			
VISTA High Temp MWIR Detectors: develop fabrication process imp yields; target achievement of wafer production scale-up to 40-50 wa time by 50%, extending cooler lifetimes 150% - 200% as a result of reducing the sensor lifecycle maintenance cost.	provements that reduce defects and increase availability afers per month while shortening sensor turn-on and coo reduced stress during temperature cycling, and substan	r and I down tially			
Manufacturability of Vertical-Cavity Surface Emitting Lasers – Phase electronics and packaging; and begin planning for manufacturing an	e II: continue pointer device development; design and de nd field testing.	evelop			
Organic Light Emitting Diode (OLED) Microdisplays – Phase II: condidentify key processes for direct patterning; perform diagnostic tests performance; identify, design, and order direct patterning equipment direct patterning initiative; install and test the initial linear sources for out of the Silicon on Insulator (SOI) backplane; demonstrate OLED	duct an initial Manufacturing Readiness Assessment (MI to enhance understanding of direct patterning device t; fabricate graphics array test cells and product wafers f r the direct patterning initiative; complete a design and to on Silicon on Insulator and direct patterning on bulk silic	RA); for the ape- on.			
Improved Focal Plane Array (FPS) - Hyperspectral – Phase II: focus demonstrate 640x480, 20 μm Very Long Wavelength Infrared FPAs models using multi-wafer lot runs.	s on detector and FPA fabrication, testing, and validation ; provide detailed FPA characterization; develop cost an	; d yield			
Radar Affordability Initiative – SPS-49: initiate design and developm deck equipment with modern, sustainable, maintainable equipment	ent of an affordable upgrade of the AN/SPS-49A(V)1 be in a high reliability high available operational environme	low nt.			
Nanocomposite Optical Ceramics (NCOC): Manufacturing Readines shift from 4 to 7 over the next two years to support transition activitie	ss Levels (MRLs) for NCOC dome manufacturing needs es associated with AIM-9X. Manufacturing tasks will targ	to et low-			

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the	Secretary Of Defense	Date:	ebruary 2016	;
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Project (Number/ P680 / Manufactur Technology Progra	nd	
B. Accomplishments/Planned Programs (\$ in Millions)		FY 2015	FY 2016	FY 2017
rate initial production (LRIP) activities in 2017 followed by full rate princlude raw material costs, powder conditioning, blank forming, heat	roduction (FRP) starting in 2018. Manufacturing activities t treatment, optical finishing and coatings.	will		
<b>FY 2017 Plans:</b> Improved Focal Plane Array (FPS) - Hyperspectral – Phase II: contine determine FPA yield for each lot by verifying FPA performance; modincrease yield.	nue producing focal plane array (FPA) lots; continue to dify manufacturing processes between each FPA lot to			
Manufacturability of Vertical-Cavity Surface Emitting Lasers – Phase continue making gains in wall plug efficiency (WPE), illuminator pow	e II: continue device development and product transitions; ver, and reliability.			
Organic Light Emitting Diode Microdisplays - Phase II: develop direct manufacturing processes (direct patterning: 0.5 um accuracy, linear uniformity); qualify the SOI process at the foundry; install the final di direct patterning lot runs; initiate a SOI qualification plan; conduct ar	ct patterning and SOI backplane; demonstrate critical source process uniformity, SOI: high dynamic range, disp irect patterning equipment; conduct iterative improvement n interim Manufacturing Readiness assessment.	blay		
Radar Affordability Initiative – SPS-49: design and develop an afford with modern, sustainable, maintainable equipment in a high reliability	dable upgrade of the AN/SPS-49A(V)1 below deck equipn ty, high availability operational environment.	nent		
VISTA High Temp MWIR Detectors: continue GaSb substrate qualit optimization; continue molecular beam epitaxy (MBE) capability sca (FPAs) on 5 inch wafers.	y improvement; continue single-detector-wafer production le up to 40 - 50 wafers per month; fabricate focal plane ar	rays		
Nanocomposite Optical Ceramics (NCOC): Continue powder condico coating related activities; measure results and assess Manufacturing	tioning, blank forming, heat treatment, optical finishing an g Readiness Levels.	t		
Title: Advanced Materials Manufacturing		6.303	5.401	5.713
<b>Description:</b> Advanced Materials Manufacturing is a series of effort range of materials such as composites, metals, ceramics, nanomate gains, these manufacturing technologies will accelerate delivery of t while reducing the cost, acquisition time and risk of our major defen- technologies undergoing development include materials for ballistic fabrication of structural components.	ts addressing advanced manufacturing technologies for a erials, and metamaterials. Through productivity and efficie technical capabilities to impact current warfighting operation se acquisition programs. Advanced materials manufactur survivability and ballistic protection, survivability and rapio	wide ency ons, ing I		

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of th	it R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense		Date: F	Date: February 2016		
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Project P680 / M Technol	e <b>ct (Number/Name)</b> ) I Manufacturing Science and nology Program			
B. Accomplishments/Planned Programs (\$ in Millions)			FY 2015	FY 2016	FY 2017	
Advanced Propulsion Initiative: Advance propulsion has a crucial r capabilities. Several technologies will be developed including Risk As-Manufactured and As-Maintained State Awareness. In addition associated with adaptive engine design and high performance ligh composites, thermal barrier coatings for high temperature structure unique manufacturing challenges associated with affordable Mediu	need to develop fuel efficient sustainable propulsion a-based Life Cycle Management for System Sustainment a a, technologies will be pursued addressing capability gaps atweight materials, organic matrix composites, oxide/oxide e and light weight alloys. Additional capabilities will focus aum-Small Engine fabrication methods including Expendab	and on les.				
Projects:						
40MM M433 Warhead Producibility (FY 2015): Achieve improved a effectiveness against personnel targets through optimization of pro avoiding high cartridge unit costs with a projected \$17/round cost r M320GL, and M32 MSGL. Secondary applications include Cannor	shot <sup>I,</sup> 3 GL,					
Automated and Rapid Boot Installation (FY 2015-2016): Achieve a installation and boot hole cutting. Improve fit and finish, reducing p hole cutting), reducing kitting, eliminating time for adhesive mixing acquisition and sustainment communities.	an F-35 Program-wide 30% reduction in touch labor for bo production span times (20s/fastener to 3s/fastener for boot , application, and vacuum bagging. Applicable to all aircra	ot : ift				
Cold Spray Repair and Rebuild Phase II - Large Structures (FY 20 to a target of 40 feet to enable large tubular component repair. App TD-63 Actuators.	015-2017): Expand the Cold Spray product envelope from plications include Seawolf Class Submarine Periscopes a	5 feet nd				
Dimensions on Day One (FY 2015, FY 2017): Demonstrate a meth numerous geometric, tooling and material factors impacting finishe tooling design to yield first article parts meeting the "dimensional re A-XX/Long Range Strike for maintaining part and aircraft tolerance vehicles.	hodology that accurately predicts and accounts for the ed composite parts enabling the correct upfront process an equirements on day 1". Applications include F-35/UCLAS es, which enables survivable, supportable and affordable a	nd S/F/ air				
Large Scale Encapsulate Ceramics - Phase II (FY 2016): Enable of Energy objective threats within the allocated weight parameters. Freduction of \$10K /sq. foot. Armor panels will be producible in the statement of the statement o	combat vehicles to defeat the large caliber Kinetic and Che Help address affordability of the armor, with an estimated shapes required by individual vehicles. Applications include	emical cost de				

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense			Date: February 2016		
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z / Defense Wide Manufacturing Science and Technology Program	Project ( P680 / M Technolo	<b>Project (Number/Name)</b> 1680 I Manufacturing Science and Technology Program		
B. Accomplishments/Planned Programs (\$ in Millions)		F	Y 2015	FY 2016	FY 2017
Abrams, which has a known protection limitation. GCV and other ve vehicles subject to large caliber KE and CE threats.	ehicles will use this technology to design those areas of				
Out of Autoclave Processing of Organic Matrix Composites (OMCs out of autoclave processable OMCs are currently limited to a servic applications. Expanding performance of OMCs to temperatures bet trade space for developing the next generation advanced propulsio frames, vanes, stators and outer by-pass ducts. Insertion of this teo (AETP) will lower cost, increase range and maintain performance for Fabrication of Non-Eroding Metallic Throat (FY 2016-2017): Scale to Throats from 4" up to 12" inner throat diameters. Applications include Missile III.	a) for Advanced Propulsion (FY 2017): Current state of the ce life of between 325F and 375F limiting advanced proput tween 400F and 625F will dramatically increase the design systems. Advanced propulsion structure includes front chnology onto the Adaptive Engine Transition Programme for the next generation tactical aircraft. the manufacturing of Thin walled, Non-Eroding Tungsten de Stage 2 & Stage 3 ICBMs as well as Stage 2 Standard	art Ision n (W)			
<b>FY 2015 Accomplishments:</b> 40MM M433 Warhead Improvement Producibility: developed inject processes; optimized mold stages to decrease time to load parts, o fragment insertion methods/tools to reduce time to fill mold with frag at reduced cycle times.	tion molding and discrete fragment insertion tooling and over-mold parts & transition to follow on stages; developed gments & settle/align fragments; enabled mold stage tran	l sitions			
Automated and Rapid Boot Installation: conducted pre-production e implementation approach; solicited Request for Proposals for press	evaluations of complex boot assemblies; determined sure sensitive adhesive applications.				
Cold Spray Repair and Rebuild Phase II - Large Structures: assess on the submarine periscopes and stern tubes of the Virginia 688, O	sed the repair and processing requirements for the large p Dhio 726, and Sea Wolf.	oarts			
Dimensions on Day One: created process methodology and identific software; tested materials for resin shrinkage and coefficient of the training; created and evaluated predictive model for a subcompone built" hardware.	ied required materials not addressed in current predictive rmal expansion; developed predictive capability methodol ent with simple modeling characteristics and compared to	ogy "as			
FY 2016 Plans:					

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense Date: February 2016								
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Projec P680 / Techno	Project (Number/Name) P680 I Manufacturing Science and Technology Program					
B. Accomplishments/Planned Programs (\$ in Millions)		Γ	FY 2015	FY 2016	FY 2017			
Cold Spray Repair and Rebuild Phase II Large Structures: expand t larger components; incorporate a means of processing long parts (4)	he capability of Cold Spray Phase I System to accommo 10 feet); develop a fully integrated "tube" repair processir	date ng line.						
Automated and Rapid Boot Installation: implement adhesive applica quality.	ation development to enable reduced cycle time and impl	roved						
Large Scale Encapsulate Ceramics - Phase II: conduct manufacturin models; produce the required thermal design power to manufacture	ng trials to scale up solutions; test full-size panels; refine the armor panels; set up a Government manufacturing f	acility.						
Fabrication of Non-Eroding Metallic Throat: study Vacuum Plasma S fabricate 4" diameter specimens and conduct thermal-mechanical p modify equipment for scale up to 6" diameter specimens; assess ins increased size and shape (diameter, thickness, length) for inner thro to limit reaction of the W throats with its carbon support structure; in for tungsten based nozzles; Use modeling, the material properties, the temperature to determine the optimal thickness requirements for the	Spray (VPS) manufacturing capability scale-up issues; roperty testing to use as a material property baseline; strumentation for control and diagnostics research neede bat diameters up to 12"; develop and test a coating syste ivestigate non-destructive evaluation (NDE) techniques the nozzle size requirements and the proposed propellar e thin walled throats.	ed to em						
FY 2017 Plans: Cold Spray Repair and Rebuild Phase II Large Structures: final integ	gration and system demonstration.							
Dimensions on Day One: scale the model up to a full-size highly cor component, and demonstrate Manufacturing Readiness Level 7 cap	mplex component, compare predictions to an as-built pability.							
Out of Autoclave Processing of Organic Matrix Composites (OMCs) capabilities for affordable OMC advanced propulsion structure inclue the art OMC systems with elevated service life ranging from 375F to	for Advanced Propulsion: develop novel manufacturing ding front frames, stators and ducts; mature current state o 625F, beyond the capabilities of BMIs and cyanate este	e of ers.						
Fabrication of Non-Eroding Metallic Throat: produce 6" specimens a specimens; study post VPS processing to assure 98% density. This scale-up issues. Conduct research to improve the manufacturability size requirements and non-destructive evaluation techniques; asses	and conduct testing; modify equipment and produce 9" included sintering and hot isostatic press (HIP) consolid of non-eroding throats; continue investigating and upda as assembly requirements for supports/insulators and	ation ting						

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secret		Date: F	ebruary 2016			
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Project ( P680 / M Technolo	roject (Number/Name) 680 I Manufacturing Science an echnology Program			
B. Accomplishments/Planned Programs (\$ in Millions)		F	Y 2015	FY 2016	FY 2017	
recommend/assess measures to reduce step down erosion in the exit cone of VPS size and processing; create a preliminary design for scale-up of nor	e; construct a material property data base as a fur n-eroding throats to 12" ID.	iction				
Title: Enterprise and Emerging Manufacturing			2.583	2.662	3.048	
<b>Description:</b> Enterprise and Emerging Manufacturing addresses advanced for defense applications. Key focus areas include direct digital (or additive) machining, robotics, assembly, and joining. Projects selected will accelera warfighting operations while reducing cost, acquisition time, and risk of major	d manufacturing technologies and business practi ) manufacturing, advanced manufacturing enterpr te delivery of technical capabilities to impact curre for defense acquisition programs.	ces ise, ent				
It is paramount for the U.S. military to improve its own agility and flexibility. burdensome acquisition cycle requiring a great amount of cost, time, secur satellite data links or a local parts database, warfighters can access compu- them to repair equipment without the need to establish supply chains or wa design based on its performance in the field.	e owing art's					
Emerging manufacturing technologies undergoing development include: a machine tool applications, and methods for exchange of 3D official technica Government and contractors.	large-scale challenge for advanced, interoperable al data throughout the supply chain and between	e the				
Cyber Initiative: The manufacturing factory floor is a growing area of concerning throughout the DoD's supply chain are continually targeted by cyber crimin critical national security information and valuable commercial intellectual pr and products; and 3) impair or deny process control, thereby damaging or systems of a manufacturing enterprise presents a different set of challenge This initiative will focus on the objective of securing the environment for Arr include: developing cyber threat models, creating a tool to visualize and sir dependencies; engaging an industry consortium for knowledge/data sharin coalesces industry needs and shares critical data; developing a cyber-phys (e.g., how to test protection for work instructions/process documentation; c protocols for information across the digital thread; and creating supplier ma a critical security control list).	rn for DoD cyber security because defense contra als seeking to: 1) steal technical data, including roperty; 2) alter data, thereby affecting processes shutting down operations. Protecting the operation is from protecting enterprise IT systems and netw herican Manufacturing on the shop floor. Efforts w nulate an attack on manufacturing to understand g/threat sharing; building an industry consortium t sical test environment for manufacturing cybersec onducting primary research into creating secure inagement standard processes and certifications	actors nal orks. ill hat urity (e.g.,				
Projects:						

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense Date: February 2016									
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Projec P680 Techn	ct (Number/f / Manufacturi ology Progra	(Number/Name) /anufacturing Science and ogy Program					
B. Accomplishments/Planned Programs (\$ in Millions)			FY 2015	FY 2016	FY 2017				
Criticality of American Manufacturing (CAM) (FY 2015): The Defense System detailed analysis of the Criticality of American Manufacturing (CAM) to the analysis will focus on the criticality of physical and programmatic clustered to support manufacturing technology and capability. The analysis will add innovation and the resiliency of the American Manufacturing & Industrial B	tems Information Analysis Center (DSIAC) will pro e resiliency and innovation defense industrial base d activity between academia, industry and governr lress the importance of human capital investment Base.	vide a . The nent to							
High Power Ultrasonic Assisted Drilling (FY 2015): addresses the problem of high costs of drilling various alloys of significant strength, High KSI Steels, IN625, and Composites by developing ultrasonic technology for hole-drilling applications to improve productivity and tool life by more than 50%. This process potentially impacts all systems that require drilling of holes.									
MTConnect Challenge Phase II (FY 2015-2016): Promote academia's edu interactive solutions to the broad U.S industrial base with the expansion or cycle times and the development of real-time production metrics for adapt	luction d								
Cyber Security for the Shop Floor – Phase II (FY 2016-2017): A follow-on this phase II project will develop a Trusted and Assured supply chain, ider provide input to DoD policies, and shape follow-on investment to mitigate Industrial Base.	from a previously funded Phase I Red Team evalu ntify threat vulnerabilities of industrial control syste threat vulnerabilities. Applications span the US De	uation, ms, efense							
<b>FY 2015 Accomplishments:</b> MTConnect Challenge - Phase II: Building upon the results of the first MT challenging Academia's role in support of the MTConnect expansion in Inc.	Connect Challenge, the phase II objective focuse dustry use.	d on							
High Power Ultrasonic Assisted Drilling: advanced AcousTech Machining to 6 by focusing on Drilling and Milling Studies of Weapons Systems Mate Feasibility of improvements were observed in the form of increased feed r torque, and burr reduction.	k ent. nd								
Criticality of American Manufacturing (CAM): began framing the ontology a of American Advanced Manufacturing (AM). This effort focused on baselin framework for CAM assessments, including: 1) definition of the key compo 2) general mapping of the AM ecosystem and its overall composition and	and ecosystem dynamics that define the "Criticality ning the initial argument and scoping the assessme onents/enablers of AM and its general taxonomy; incentive structure; and 3) framing of areas of AM	y" ent							

Exhibit R-2A, RDT&E Project Justi	fication: PB	2017 Office	of the Secre	tary Of Defe	nse				Date: February 2016				
Appropriation/Budget Activity 0400 / 3				R-1 Pr PE 060 Manuf Progra	rogram Elei 03680D8Z / acturing Sci am	nent (Numb Defense Wid ence and Te	<b>er/Name)</b> de chnology	Project P680 / Techno	t <b>(Number/Name)</b> Manufacturing Science and logy Program				
B. Accomplishments/Planned Prog	grams (\$ in N	<u>/lillions)</u>							FY 2015	FY 2016	FY 2017		
"dominance" vs. "relevance" with req out a structure for future assessment manufacturing institutes and Commu	uisite sector/ s as well as inities of Inter	technology of to bolster fut rest).	differentiatior ure dialogue	n. Addressed on current i	l some gene nitiatives an	eral questions d communiti	s in order to I es (among U	ay .S.					
<b>FY 2016 Plans:</b> MTConnect Challenge – Phase II: Focus on data accumulation in obtaining and exchanging information on the factory floor. Market the challenge opportunities for awareness to the Society of Manufacturing Engineers, NTMA, and Colleges for participa and submittals. Develop judging criteria and initiate development of the challenge review criteria.													
Cybersecurity for the Shop Floor – Phase II: follow-on efforts from a previously funded Phase I Red Team evaluation that focused on multiple threat levels triggered on manufacturing equipment at the shop floor level. Assess performance of companies for vulnerabilities after implementing the new DFAR requirements.													
<b>FY 2017 Plans:</b> Cybersecurity for the Shop Floor – P control systems, provide input to Dol assessment results that discuss DFA	hase II: deve ) policies, sh \R requireme	lop a trusted ape follow-o nts and supj	l and assure n investmen pliers' mitiga	d supply cha t to mitigate tion and cos	in, identify t threat vulne t implication	hreat vulnera rabilities, and s.	abilities of inc d document	lustrial					
Cybersecurity Initiative: continuing a and simulate an attack on manufactu sharing/threat sharing; building an in cyber-physical test environment for r documentation; conducting primary r supplier management standard proce	ind expanded iring to under dustry conso nanufacturing esearch into esses and ce	l efforts will i stand deper rtium that co cybersecur creating sec rtifications (e	include deve ndencies; en palesces indu tity (e.g., how cure protocol e.g., a critica	loping cyber gaging an in ustry needs a v to test prot s for informa Il security co	threat mod dustry cons and shares o ection for we tion across ntrol list).	els, creating ortium for kn critical data; d ork instructio the digital the	a tool to visu owledge/data developing a ns/process read; and cre	alize a eating					
				Accon	nplishment	s/Planned P	rograms Su	btotals	22.785	20.245	21.311		
C. Other Program Funding Summa	<mark>ry (\$ in Milli</mark>	<u>ons)</u>	FY 2017	FY 2017	FY 2017					Cost To			
Line Item	<u>FY 2015</u>	<u>FY 2016</u>	Base	000	Total	<u>FY 2018</u>	<u>FY 2019</u>	<u>FY 2020</u>	<u>5 FY 2021</u>	Complete	Total Cost		
• (BA3) 0603680F:	-	-	-	-	-	-	-	-	-				
Air Force Man Iech • (BA3) 0603680N: Navy ManTech	-	-	-	-	-	-	-	-	-				

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense									Date: February 2016		
Appropriation/Budget Activity 0400 / 3			<b>R-1 Pr</b> PE 060 <i>Manuf</i> <i>Progra</i>	R-1 Program Element (Number/Name)PrPE 0603680D8Z / Defense WidePeManufacturing Science and TechnologyTeProgramPr				<b>Project (Number/Name)</b> P680 <i>I Manufacturing Science and</i> <i>Technology Program</i>			
C. Other Program Funding Summa	ry (\$ in Milli	ons <u>)</u>									
			FY 2017	FY 2017	<u>FY 2017</u>					Cost To	
Line Item	FY 2015	<u>FY 2016</u>	<b>Base</b>	000	<u>Total</u>	FY 2018	FY 2019	FY 2020	<u>FY 2021</u>	<u>Complete</u>	<b>Total Cost</b>
<ul> <li>(BA7) 0708045A: Army ManTech</li> <li>Industrial Preparedness</li> <li>(BA7) 0603680S: DLA ManTech</li> </ul>	-	-	-	-	-	-	-	-	-		
Remarks											

#### D. Acquisition Strategy

Not applicable for this item. Outyear data for "Other Program Funding" is contained within the Service budgets.

#### E. Performance Metrics

The majority of project performance metrics are specific to each effort and include measures identified in the project plans. The metrics include items such as target dates from project work break down schedules, production measures, production goals, production numbers and demonstration goals and dates. In addition, generic performance metrics applicable to the Defense-Wide Manufacturing, Science and Technology (DMS&T) program includes attainment of a previous administration goal, "Speed technology transition focused on warfighting needs". The metrics for this objective and the objective of DMS&T is to transition 30% of completing demonstrations program per year.

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense										Date: February 2016		
Appropriation/Budget Activity 0400 / 3				<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>				<b>Project (Number/Name)</b> P350 <i>I Manufacturing Innovation Institutes</i>				
COST (\$ in Millions)	Prior Years	FY 2015	FY 2016	FY 2017 Base	FY 2017 OCO	FY 2017 Total	FY 2018	FY 2019	FY 2020	FY 2021	Cost To Complete	Total Cost
P350: Manufacturing Innovation Institutes	47.437	65.350	136.498	137.087	-	137.087	114.770	92.556	58.138	34.916	Continuing	Continuing

### A. Mission Description and Budget Item Justification

Technological innovation and leadership in manufacturing are essential to sustaining the foundations of economic competitiveness to maintain technological advantage and global dominance for our military. To support these goals, Manufacturing Innovation Institutes (MIIs), each led by non-profit 501(c) entities, will serve as regional hubs to accelerate technological innovation into commercial applications and concurrently develop the educational competencies and production processes via shared public-private sectors. Collaborative execution and funding by the Departments of Defense (DoD), Energy (DOE), and Commerce (DoC), the National Aeronautics and Space Administration (NASA), and the National Science Foundation (NSF) to support the establishment of these MIIs will spur industry cost-share for manufacturing innovation and quickly develop a pathway for technology-focused regional hubs for collaboration among government, industry, and academia that will meet critical government and Warfighter needs. The concept of these institutes is described in the President's National Science and Technology Council report by the Advanced Manufacturing National Program Office entitled, "National Network for Manufacturing Innovation: A Preliminary Design," published in January 2013.

Each of the eight DoD-led MIIs addressed in this budget is expected to be self-sustaining, without reliance on federal sustainment funding, by the end of the respective cooperative agreement (CA) period between the federal government and the non-profit-led consortium. This CA period is typically for five years, with the option to extend the agreement up to two years for the benefit of DoD projects, technical achievement, etc., to fully leverage the minimum 1:1 cost share. All subsequent (post-CA) federal funding provided to any MII will be on a specific project basis by the requirements generators, either within or external to DoD.

Each of the eight DoD-led MIIs is intended to:

1) Bring together industry, universities and community colleges, federal agencies, and state and local governments and organizations to create regionally-based but nationally-impactful public-private partnerships underpinning the formation of sustainable manufacturing innovation ecosystems

2) Accelerate innovation to bridge the gap between Research and Development (R&D) and deployment of technological innovations in domestic production of goods

3) Invest in industrially relevant manufacturing technologies with broad applications, accelerating innovation within DoD and across all manufacturing sectors to increase U.S. competitiveness

- 4) Provide shared assets to help companies access cutting-edge capabilities and equipment
- 5) Create an unparalleled environment to educate and train students and workers in advanced manufacturing skills
- 6) Focus on maturing the associated manufacturing technologies from Manufacturing Readiness Level (MRL) 4 to 7

The first and second year of each of these new institutes is devoted to establishing a sustainable business model, with continued refinement throughout the full period of the cooperative agreement, including: expanding the institute's membership base (as appropriate); establishing and solidifying revenue streams (e.g., funding from new R&D activity, membership fees, training and workforce development, certification and licensing, etc.); establishing provisional Executive Council and Technical Advisory committees to execute the business of each institute; finalizing Intellectual Property plans; developing technology roadmaps to inform investment strategies;

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense Date: Februar						
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Project (Nu P350 / Manu	t (Number/Name) Manufacturing Innovation Institute			
opening industrial commons to provide for shared resource facilities available establishing complementary relationships between MIIs; analyzing the U.S. a institute portfolio and address critical requirements; and further developing na	to all institute members; initiating workforce train nd Global industrial base in partnership with othe tional technology roadmaps.	ning progran er governme	ns in ea nt agen	ch technolog cies to build	y area; upon the	
B. Accomplishments/Planned Programs (\$ in Millions)		FY 2	2015	FY 2016	FY 2017	
Title: Institute #1 – National Additive Manufacturing Innovation Institute (Amer	ica Makes)	1	5.492	1.011	1.038	
<b>Description:</b> Additive manufacturing (i.e., "3D printing") is a process of joining usually layer upon layer, as opposed to subtractive manufacturing methodolog additive manufacturing will benefit the DoD by enabling lifecycle cost savings "focused logistics" – getting the right part in the right place in just the right time local supply chains. This MII was established in 2012, with cooperative agreen 2015, and DoD program management costs included in subsequent fiscal year responsibilities are completed.	g materials to make objects from 3D model data, gies such as traditional machining. Advanced and enhanced capabilities, including moving tow e – for wartime and humanitarian missions using ment funding included in this budget through FY ars until all R&D projects, reporting, and fiduciary	ard				
<i>FY 2015 Accomplishments:</i> Launched a third call for R&D projects based on an updated industry-driven te additional applied research projects with highest potential for industry and gov formed new supply chains for DoD, including small businesses; established a extend reach into that region. Launched education and workforce training initia agencies for training and certification programs. Rolled out upgrades to on-line and knowledge base of institute-developed intellectual property and data.	echnology roadmap; competitively awarded vernment shared benefit; created an ecosystem Satellite Center at University of Texas at El Pas atives, including partnering with multiple Govern e collaboration tools including a capabilities sear	hat o to ment ch				
<i>FY 2016 Plans:</i> Launch a fourth call for R&D projects based on the institutes' most current tec additional applied research projects with highest potential for industry and gov Development Organizations to define needed industry standards; launch a pro DoD; launch enhanced processes for transitioning technologies developed by proposition to members and support MII self-sustainability; continue education	hnology roadmap; competitively review and awa vernment shared benefit; lead a group of Standa bject to enable low-cost sustainment capabilities the MII; implement initiatives to increase the va n and workforce training initiatives.	rd rds for ue				
<b>FY 2017 Plans:</b> Complete execution of all prior year awarded projects and make results availate for the Cooperative Agreement ends on August 31, 2017. Program managem through Aug 31, 2019 for the close-out of all R&D projects, cost share accrual to completion of RDT&E fiduciary responsibilities.	able in the knowledge base. Period of performan ent subsequently continues to provide oversight , reporting, and transition to sustainability, in add	ce lition				
<i>Title:</i> Institute #2 – Digital Manufacturing and Design Innovation Institute		1	3.542	24.021	13.488	

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary (	Of Defense		Date: F	ebruary 2016	6
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Project (Number/Name) P350 I Manufacturing Innovation In			n Institutes
B. Accomplishments/Planned Programs (\$ in Millions)		[	FY 2015	FY 2016	FY 2017
<b>Description:</b> This national institute focus is on the implementation of the Digitat the lifecycle of a manufactured product encompassing data from design, product quality, maintenance and sustainment. It includes the analysis of this data to remarket, the elimination of barriers between design, manufacturing and sustainment in a way that is seamless and transparent.	I Thread, the unencumbered flow of data acro ction, supply, sourcing, inventory, assembly, educe the time and cost of bringing new produ nent by using both product data and process of	oss icts to data			
Technology thrust areas: advanced manufacturing enterprise; intelligent machine cyber manufacturing system security.	nes; advanced analysis; open source platform	i; and			
This MII was established in February 2014, with cooperative agreement funding 2018.	g contribution included in this budget through	FY			
<b>FY 2015 Accomplishments:</b> Awarded 32 projects in 12 proposal calls in the technology thrust areas listed a \$30 million was from DoD and \$31 million was Cost Share. Worked with the DA to move technologies developed in the AVM program to transition and commer projects with World Business Chicago and the Department of Commerce Natio Manufacturing Extension Partnership (MEP). Completed the DMDII Headquarte out of the new facility from the State of Illinois and the City of Chicago and the or multiple software systems in the manufacturing lab. Initiated the Digital Manufacturing access to the tools of manufacturing innovation for companies, un	bove totaling approximately \$61 million, of wh ARPA Adaptive Vehicle Make (AVM) Program cialization. Initiated workforce development nal Institute of Standards and Technology (NI ers by securing \$16.5M in funding for the build donation of more than \$3 million in equipment acturing Commons open platform project whic iversities, institutes and entrepreneurs.	ich ST) J and h will			
<b>FY 2016 Plans:</b> Launch a call for proposals in the Spring of 2016 with a particular topic in each result of approximately 15 new projects with a planned value of \$7 - \$10 million award projects in the technology thrust areas identified above. Launch the Beta Revise the Technology Roadmap and Strategic Investment Plan to lead the technolog. Activate education and workforce development projects: 1Digital Manua comprehensive breakdown of digital manufacturing (DM) skill sets and create NIST/MEP on cooperative mechanisms such as "Train the Trainer" programs a enterprises (SME) network to implement workforce development training and e a three to five day workshop on digital analytics in the manufacturing environment	of the technology thrust areas, with an anticip a. Conduct multiple Proposal Call Workshops, a version of the digital manufacturing common chnology domain in the completion of a Digital ufacturing Skills Classification "Taxonomy" to be job profiles that match industry needs; work and utilization of their existing small and mediu ngagement; Digital Analytics Boot Camp to de ent; Digital Manufacturing-101 to develop DM	ated and s. create with m evelop			

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense Date: February 2016						
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	<b>Project (I</b> P350 / <i>M</i> a	roject (Number/Name) 350 / Manufacturing Innovation Institute			
B. Accomplishments/Planned Programs (\$ in Millions)		F	Y 2015	FY 2016	FY 2017	
open-source, online courses through Coursera for general public but target ex Medium-sized (SME) Manufacturers.	kisting engineers, lead plant managers at Small-	and-				
<b>FY 2017 Plans:</b> Proposal calls are planned to occur approximately every six months consisting approximately 30 new projects with a planned value of \$10 million. Conduct r projects in the technology thrust areas identified above. Continue the on-going FY 2016. Instantiate a networking and capability matching mechanism with a website. Revise the Technology Roadmap and Strategic Investment Plan to I Digital Thread. Announce the commercialization of new digital manufacturing Significantly scale up commercialization, skill development and workforce device relationships with other government agencies (e.g. NIST/MEP).	g of 3 to 4 project calls each, resulting in nultiple Proposal Call Workshops, and award g workforce development projects initiated in Il new project calls and an online version on the ead the technology domain in the completion of and design technologies and industry capabilitie relopment efforts from research projects and	a s.				
<i>Title:</i> Institute #3 – Lightweight and Modern Metals Manufacturing Innovation (LIFT))	Institute (Lightweight Innovations for Tomorrow		13.428	27.913	13.521	
<b>Description:</b> Advanced lightweight metals retain properties comparable to here reduction in a variety of components and products with significant energy saving up research across multiple areas to accelerate market expansion by applying approach, addressing a lack of design guides and certifications as well as cost the development of an advanced lightweight metal U.S. supplier base and to expanded, unmanned, and Warfighter systems as well as benefits for commerced	ht ze of					
Technology thrust areas: (1) priority metal classes and its alloys of advanced high-strength steels, titani development needs grouped into six pillars: melt processing; powder process tooling, coatings, and joining and assembly; (3) Crosscutting themes: Integrat design, life-cycle analysis, validation/certification, cost modeling, supply chain	gile ,					
This MII was established in February 2014, with cooperative agreement funds	programmed in this budget through FY 2018.					
<b>FY 2015 Accomplishments:</b> Completed project call #1 with a portfolio of 13 projects totaling approximately described above. Second Project call initiated with a planned portfolio value of funds, with projects targeted in key core areas of: applications of new/novel methods.	\$9 million, awarded in technology scope areas f approximately \$10 million in government netals and alloys, primary and secondary metal					

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the S	Date: February 2016					
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Proje P350	roject (Number/Name) 350 / Manufacturing Innovation Institute			
B. Accomplishments/Planned Programs (\$ in Millions)			FY 2015	FY 2016	FY 2017	
manufacturing processes, and development of additional products util education workforce projects. Built infrastructure to design and implen region [OH, MI, IN, TN, KY]. The five-State teams involve over 135 of development, labor, industry, state and local government. Launched a contest partnering Tennessee manufacturers and student teams to rai technical education.	izing lightweight and modern metals. Launched three ment workforce education solutions in its five-State fficials in education, workforce development, economic an advanced manufacturing student engagement video ise career awareness and increase enrollment in caree	) er and				
With Tennessee Tech, designed a virtual reality demonstration and "c lightweighting technologies. Created an interactive, web-based Scien Mission bringing lightweight technologies and materials and put it in so use it. Created 45 boot camps integrating metals and materials, lightw and community college instructors, reaching over 1,000 teachers in th LIFT partnership reached 206. Includes 108 organizations with memb partners.	and ) d to chers e					
<b>FY 2016 Plans:</b> Project calls are planned to occur every six months, with a planned var project calls and award projects in the previously described technolog opportunity-trends) analyses along with road mapping to update the m part of that exercise, will conduct defense-focused workshop designed applications. Will introduce the small and medium enterprise (SME) of to propose small technology venture projects to a panel of large indus layout and equipment installation in the headquarters laboratory facilit resource materials to supplement and improve education from K-12 th on metals, materials, lightweighting technologies and processes. Worl and learn" initiative to innovate and expand internships, apprenticeship based learning into manufacturing programs at the secondary and pos- outreach to small and medium enterprises (SME) to additional states of workforce initiatives targeting military veterans. Initiate technology tran- include training across various levels of the workforce as needed.						
Project calls are planned to occur every six months, with a planned va will conduct several technology demonstrations and workshops to dise	alue of approximately \$15 million for the year. In additions seminate and implement the manufacturing technologies	n, es				

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretar		Date: F	ebruary 2016		
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Project (N P350 / Ma	ect (Number/Name) ) / Manufacturing Innovation Institu		
B. Accomplishments/Planned Programs (\$ in Millions)		F	( 2015	FY 2016	FY 2017
developed during our initial project calls. Conduct a series of workshops target the nation. LIFT will develop a replicable, scalable roadmap to building a tec – incorporating the new solutions "tested" in the five-State LIFT region – that nation. Continue to invest in education and workforce development solutions economic development resources to help create a coordinated economic development expansion of the "work and learn" initiative developed in FY 2016.	oss orce e nd				
<i>Title:</i> Institute #4 Integrated Photonics Manufacturing Innovation Institute (Ar Photonics)	ated	14.019	33.330	25.390	
<b>Description:</b> Integrated photonics manufacturing advances the promise of u and photonics that will deliver previously unattainable performance in speed, differentiating benefits for defense applications such as high-speed signal pro and computation, sensing, imaging and targeting. This institute will establish domestic integrated photonics manufacturing. This MII will include responsive photonics-electronics integrated design tools, and advances in packaging, as to catalyze a vibrant, enduring integrated photonics domestic industrial base, semiconductor industry.	nics ing ort ncing ss,				
This MII was established in 2015, with cooperative agreement funding progra	ammed in this budget through FY 2019.				
<b>FY 2015 Accomplishments:</b> Awarded a Cooperative Agreement, and initiated the stand-up of this new instinctives that have been refined through lessons learned. Convened first instisteering committee. Integrated DoD and Other Government Agencies with in call for a first round of applied R&D pilot projects and selected project contract to Manufacturing Centers of Excellence in Inline Control and Test, Electronic Wafer and Assembly. Initiated institute functions for design submission, design coordination of assembly, multi-project wafer runs and product validation.	oD ata : d,				
<b>FY 2016 Plans:</b> Achieve initial operational capability of the integrated photonics manufacturing photonic integrated circuit design tools, a multi-project wafer capability with a test tools and facilities. Conduct second round of applied R&D project calls a in the roadmapping phase. These core areas include: Very High Speed Digitized to the conduct second round of applied R&D project calls a second round project calls a second round of applied R&D project calls a second round of applied R&D project calls a second round project calls a seco	ng innovation ecosystem, including more robust a broker function, and new package, assembly, a and award projects in the key core areas identifie al Data and Communication Links, Analog RF	and ed			

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary	Of Defense	Date: February 2016				
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z / Defense Wide Manufacturing Science and Technology Program	Proje P350	roject (Number/Name) 350 / Manufacturing Innovation Institu			
B. Accomplishments/Planned Programs (\$ in Millions)		ſ	FY 2015	FY 2016	FY 2017	
Applications, Integrated Photonics Sensors, and Photonic Integrated Circuit A for silicon and indium phosphide photonics integrated circuits that can be used defense contractors through an affordable multi-project wafer capability. Estat packaging facility to drive down costs in this critical area. Develop automated assembly and packaging of photonic integrated components. Continue develop force through focused education, webinars, and training programs.	rray Technologies. Develop process design kits d to prove out new designs by DoD labs and blish a state-of-the-art integrated photonics prot tools for cost-effective high volume end-to-end pment of a world-class integrated photonics wo	s otype ork				
<b>FY 2017 Plans:</b> Implement lessons-learned optimizations of the integrated photonics manufact improvements in photonic integrated circuit design tools, multi-project wafer car and facilities. Conduct additional rounds of applied R&D project calls and awar roadmapping phase. Transition FY 2016 projects' output to the supply chain. integrated photonics work force through establishment of master's level prograt transition key capabilities from this institute to ongoing DoD programs requiring	nary ols ne S					
<i>Title:</i> Institute #5 – Flexible Hybrid Electronics Manufacturing Innovation Instit Manufacturing Institute)	ute (Nextflex – America's Flexible Hybrid Electr	onics	8.144	31.140	21.688	
<b>Description:</b> Flexible hybrid electronics manufacturing involves highly tailorate that combine thinned components manufactured from traditional processes will processes. This institute will invest in prototyping and scale-up of manufacturing circuits, and hybrid fabrication that will enable defense and commercial applicate and integrated array antennas, medical devices and soft robotics devices, and Weight And Power plus Cost) for electronic systems. This institute will establis containing design, packaging, assembly and test automation research and wor accessed by small, medium and large companies as well as academic institute sustainable domestic industrial base which can rapidly respond to global need. MII was established in 2015, with cooperative agreement funds programmed in the stablished in 2015.						
<b>FY 2015 Accomplishments:</b> Awarded a Cooperative Agreement and established this new MII following the through lessons learned in solicitations and standup of Institutes 1-4. Conduction	processes used for previous institutes as refine ted initial technology road mapping activities w	ed ith				

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense Date: February 2016					
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	Proje P350	ect (Number/Name) ) I Manufacturing Innovation Institutes		
B. Accomplishments/Planned Programs (\$ in Millions)		[	FY 2015	FY 2016	FY 2017
Government Subject Matter Experts. Released the first project call (PC-1) for areas identified within the road mapping activities.	or applied manufacturing projects in the key core				
<b>FY 2016 Plans:</b> Build membership and release Participation Agreement and Intellectual Prop through industry-led technology roadmapping supporting the innovation eco project calls in core areas identified within the road mapping activities. Initiat	perty Policy. Continue to refine core investment a system. Initiate two rounds of applied manufactute plans for workforce development projects.	ireas iring			
<b>FY 2017 Plans:</b> Continue to refine core investment areas supporting the innovation ecosyster project calls in core areas, with each project including components of workford areas are areas.	em. Initiate two rounds of applied manufacturing prce development.				
Title: Institute #6 - Revolutionary Fibers and Textiles Manufacturing Innovat	ion Institute		0.725	17.583	21.962
<b>Description:</b> The RFT-MII will address the spectrum of manufacturing chall from design to end products. It will support an end-to-end innovation 'ecosys manufacturing and leverage domestic manufacturing facilities to develop an will provide innovative system demonstrations based on robust design and subject matter experts, suppliers, and workforce development opportunities. This MII will be established in early 2016, with cooperative agreement funds	enges associated with revolutionary fibers and te stem' in the U.S. for revolutionary fibers and textil d scale-up manufacturing processes. The RFT-M simulation tools, pilot production facilities, a roster through targeted training and curriculum program programmed in this budget through FY 2020.	xtiles, es III r of ıs.			
<b>FY 2015 Accomplishments:</b> Programmatic planning for establishment of this new institute, including prog development, proposal reviews, and awardee selection, to support planned	gram management and acquisition teams BAA cooperative agreement award in September 201	5.			
<b>FY 2016 Plans:</b> Award a Cooperative Agreement and establish this new MII following the pro- through lessons learned in solicitations and standup of Institutes 1-5. Condu- Complete a data call for a first set of applied R&D projects and award project textile knowledge management repository and textile design tools, Innovative Technology, and Innovative product realization in Next Generation non-Weat	ocesses used for previous institutes and as refine uct initial technology road mapping activities. It contracts in the technology areas of: Fiber and e Product realization in Next Generation Wearab arable Technology.	ed le			
<b>FY 2017 Plans:</b> Continue to refine core investment areas supporting the innovation ecosyste core areas. Execute workforce development projects.	em. Initiate two rounds of applied R&D project ca	Ills in			
<i>Title:</i> Institutes #7 and #8 - Technology Areas in Development			-	1.500	40.000

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the Secretary Of Defense		Date: February 2016			
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	<b>Project (Number/Name)</b> P350 / Manufacturing Innovation Institutes			
B. Accomplishments/Planned Programs (\$ in Millions)		FY 2015	FY 2016	FY 2017	
<b>Description:</b> Two new Manufacturing Innovation Institutes are in acquisition to be established in 2017. Some of the candidate technology focus areas cur are: Biotech - Regenerative Medicine; Biotech - Continuous Manufacturing of Thread – Cybersecurity in manufacturing; Advanced Machine Tools and Control close proximity to robots. Cooperative Agreement funds are programmed in the <b>FY 2016 Plans:</b> Establish program management structure at the Services and OSD levels to a implementation and acquisition planning and execution, establishing one new	planning, one to be established in late 2016, and rently under consideration for these two institute Pharmaceuticals; Securing the Manufacturing I rol System; and Soft Robotics – Humans workin his budget from FY 2017 through FY 2021. Support technology selection for each institute, a r institute in 2016 and one in 2017.	d one es Digital g in nd			
<b>FY 2017 Plans:</b> Award Cooperative Agreements and establish each new MII following the prot through lessons learned in solicitations and standup of Institutes 1-6. Conduc Complete a data call for a first round of S&T projects and award project contra the road mapping activities.	cesses used for previous institutes and as refinent of initial technology road mapping activities. acts in the key core technology areas identified	ed within			
	Accomplishments/Planned Programs Sub	totals 65.350	136.498	137.087	
<u>C. Other Program Funding Summary (\$ in Millions)</u> N/A <u>Remarks</u> D. Acquisition Strategy					
	1 <i>0</i> <del>-</del> 1 <i>0</i>				

Each Manufacturing Innovation Institute is established through a competitive selection process. The executing military department or agency, in close and continuous coordination with OSD ManTech, publishes a formal solicitation for proposals describing the scope of required activities and extensive proposal evaluation criteria. Non-Profit Organizations (including universities) are eligible to bid, and each bidder forms a broad consortium of industry and academic partners. The executing military department or agency uses a team of government experts to evaluate each proposal against the evaluation criteria and selects a winning consortium. The final terms of the cooperative agreement between the selectee and the federal government are then negotiated and the CA is signed. Throughout and after completion of this process, the federal government makes clear that members of non-selected teams are encouraged to join the selected consortium as conditions permit.

#### E. Performance Metrics

Experience gained to-date reinforces that the MIIs themselves must be principally responsible, with the Government's oversight, input, and concurrence, for managing metrics to measure progress against objectives. The DoD continues reviewing metrics for each MII at several levels (for example, DoD/funding agency level, individual institute level, and specific technology project level) and is working with each institute to refine specific technology or site-specific measures. At a minimum, the institutes

Exhibit R-2A, RDT&E Project Justification: PB 2017 Office of the second se	he Secretary Of Defense	Date: February 2016
Appropriation/Budget Activity 0400 / 3	<b>R-1 Program Element (Number/Name)</b> PE 0603680D8Z <i>I Defense Wide</i> <i>Manufacturing Science and Technology</i> <i>Program</i>	<b>Project (Number/Name)</b> P350 <i>I Manufacturing Innovation Institutes</i>
<ul> <li>are charged with ensuring that key elements of their innovation e elements of that ecosystem. The following four categories of met 1. Impact on U.S. Innovation Ecosystem</li> <li>2. Financial Sustainability</li> <li>3. Education and Advanced Manufacturing Workforce Developmed. Technical Advancement</li> <li>Specific metrics and the annual cycle for measuring progress agar expertise, and organizational structure. The Department is strivin upon technological advancements and the industrial base.</li> </ul>	cosystem will be matured and made widely available by for rics have emerged as common focus areas. ent ainst benchmarks are developed for each consortium and g to ensure that the assessment process captures and art	ostering collaborations between appropriate reflect that MII's unique technology capability, iculates the benefits to national security based